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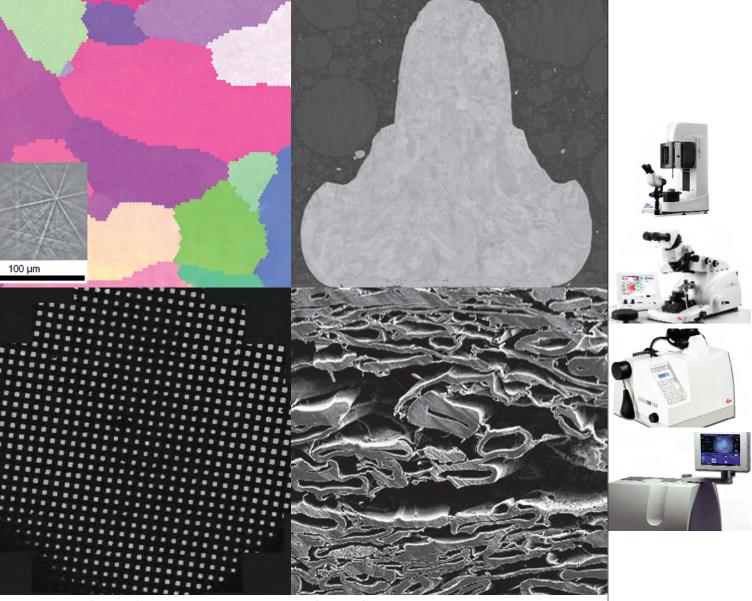
EXPO Issue

Microscopy & Microanalysis 2010

68th Annual Meeting of the Microscopy Society of America 44th Annual Meeting of the Microbeam Analysis Society 43rd Annual Meeting of the International Metallographic Society 37th Annual Meeting of the Microscopical Society of Canada/ Société de Microscopie du Canada

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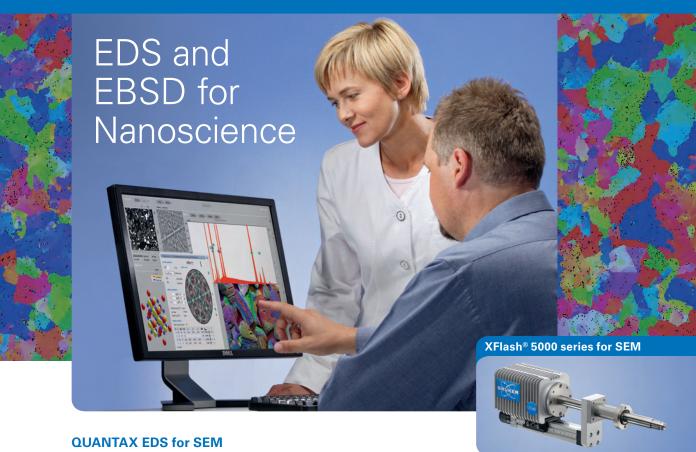
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Microscopy and Microanalysis is published bimonthly in February, April, June, August, October, and December by Cambridge University Press. Two supplements (Expo and Proceedings) are published in June and August.

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Office of Publication

Cambridge University Press, 32 Avenue of the Americas, New York, NY 10013-2473, USA; Tel: (212) 337-5000; Fax: (212) 337-5959.

Advertising Sales & Production

M.J. Mrvica Associates, Inc., 2 West Taunton Avenue, Berlin, NJ 08009, USA; Tel: (856) 768-9360; Fax: (856) 753-0064.

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Microscopy and Microanalysis

An International Journal for the Biological and Physical Sciences

Volume 16, Supplement 1
Portland, Oregon, USA
August 1-5, 2010

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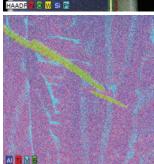
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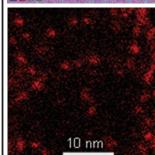
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